

1079 U.S. PTO
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PATENT NUMBER and
ISSUE DATE

U.S. UTILITY Patent Application

APPL. NUM.	FILING DATE	CLASS	SUBCLASS	GAU	EXAMINER
10061514	02/01/2002	216		65 1738	Alonso

INVENTORS: Hest. Jeffery;

CONTINUING DATA (if any):

RELATED APPLICATIONS VERIFIED:

<input checked="" type="checkbox"/> US. 6151514 NOT PUBLISHED	<input type="checkbox"/> RESCIND	ATTORNEY DOCKET NO.
<input type="checkbox"/> Yes <input checked="" type="checkbox"/> No		10010480-2
<input type="checkbox"/> Yes <input checked="" type="checkbox"/> No		
Applicant has acknowledged Examiner's initials		
CITE - Substrate and method of forming substrate for fluid ejection device		
U.S. DEPT. OF COMMERCE/PTO-1351 (Rev. 1-9-93)		

NOTICE OF ALLOWANCE MAILED		CLAIMS ALLOWED	
		Total Claims Print Claim for O.G	
		DRAWING	
		Sheets Drwg.	Figs. Drwg.
		Print Fig.	
		Application Examiner	
ISSUE FEE		Primary Examiner	
Amount Due	Date Paid		
TERMINAL		PREPARED FOR ISSUE	
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